

Notice of References Cited

Application/Control No.

10/629,866

Applicant(s)/Patent Under
Reexamination
LEE ET AL.

Examiner

Daniel Kim

Art Unit

2185

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0142660	10-2002	Abe, Takashi	439/631
*	B	US-6,725,314	04-2004	Dong, Lam S.	710/305
*	C	US-2003/0043613	03-2003	Doblar et al.	365/63
*	D	US-2002/0041020	04-2002	Ono et al.	257/685
*	E	US-6,081,862	06-2000	Dixon et al.	710/307
*	F	US-2005/0262323	11-2005	Woo et al.	711/167
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.